

## WEST Search History





DATE: Thursday, February 02, 2006

Hide?	<u>Set</u> <u>Name</u>	<u>Query</u>	<u>Hit</u> <u>Count</u>
		<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=OR</i>	
<input type="checkbox"/>	L11	L9 or L10	98
<input type="checkbox"/>	L10	L8 and (\$ppm with hydrogen)	25
<input type="checkbox"/>	L9	L8 and terminat\$4	81
<input type="checkbox"/>	L8	(rins\$3 with hydrogen) and silicon and (megasonic\$4 or ultrasonic\$4 or vibrat\$6)	268
<input type="checkbox"/>	L7	L5 and (( deuterium) with \$ppm)	1
<input type="checkbox"/>	L6	L5 and ((hydrogen or deuterium) with \$ppm)	12
<input type="checkbox"/>	L5	L4 and wafer	423
<input type="checkbox"/>	L4	(hydrogen or deuterium) and (terminat\$4 with surface) and (megasonic or ultrasonic or vibrat\$4)	1323
<input type="checkbox"/>	L3	L2 and wafer	1322
<input type="checkbox"/>	L2	L1 and silicon	5182
<input type="checkbox"/>	L1	(hydrogen or deuterium) and terminat\$4 and (megasonic or ultrasonic or vibrat\$4)	11523

END OF SEARCH HISTORY

## WEST Search History





DATE: Saturday, December 16, 2006

Hide?	<u>Set</u> <u>Name</u>	<u>Query</u>	<u>Hit</u> <u>Count</u>
	<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=OR</i>		
<input type="checkbox"/>	L26	clean\$3 with vibration with terminat\$3 with silicon	1
<input type="checkbox"/>	L25	L24 and (Si or silicon) and (110 or 001)	371
<input type="checkbox"/>	L24	(terminat\$4 with (hydrogen or deuterium)) and (vibrat\$4 or ultrasonic\$4)	966
<input type="checkbox"/>	L23	L21 and (terminat\$4 with (hydrogen or deuterium))	15
<input type="checkbox"/>	L22	L21 and terminat\$4	97
<input type="checkbox"/>	L21	deuterium and ultrasonic and clean\$3	218
<input type="checkbox"/>	L20	(terminat\$3 with deuterium) and vibrat\$	6
<input type="checkbox"/>	L19	(terminate with deuterium) and vibrat\$	2
<input type="checkbox"/>	L18	(terminate with deuterium) and clean\$3	7
<input type="checkbox"/>	L17	(terminate with deuterium) and (ultrasonic\$4 or vibrat\$4) and clean\$3	2
<input type="checkbox"/>	L16	(terminate with (silicon or hydrogen)) and vibrat\$4 and ((heavy adj hydrogen) or deuterium)	8
<input type="checkbox"/>	L15	(RCA with (SC-1 or SC1)) same (reduc\$5 with OH)	7
<input type="checkbox"/>	L14	(orient\$5 with (100 or 001 or 110)) and (DHF with clean\$3)	8
<input type="checkbox"/>	L13	L12 and (DHF with clean\$3)	86
<input type="checkbox"/>	L12	L11 and (DHF with surface)	153
<input type="checkbox"/>	L11	DHF and ((wafer or silicon or substrate) with (100 or 001 or 110))	550
<input type="checkbox"/>	L10	L9 and (110 or 100 or 001)	71
<input type="checkbox"/>	L9	(clean\$3 with solution with HF with DI)	86
<input type="checkbox"/>	L8	L7 and (HF with solution with DI)	97
<input type="checkbox"/>	L7	((100 or 110) with (silicon or wafer or substrate)) and clean\$3 and (HF with DI)	211
<input type="checkbox"/>	L6	((100 or 110) with (silicon or wafer or substrate)) and clean\$3 and (HF with (dissolved adj oxygen))	8
<input type="checkbox"/>	L5	(clean\$3 with (wafer or substrate) with HF with dissolved with oxygen)	2
<input type="checkbox"/>	L4	HF same clean\$3 same (dissolved adj oxygen)	21
<input type="checkbox"/>	L3	L2 and HF	39
<input type="checkbox"/>	L2	L1 and ((dissolved with oxygen) with (ppm or ppb))	81
<input type="checkbox"/>	L1	(semiconductor adj (wafer or substrate)) and ((wafer or substrate) same clean\$3)	38694

END OF SEARCH HISTORY